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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Pan et al.

**Serial No.:** 09/259,145

**Filed:** February 26, 1999

**For:** WELL-DRIVE ANNEAL  
TECHNIQUE USING PREPLACEMENT  
OF NITRIDE FILMS FOR ENHANCED  
FIELD ISOLATION

**Examiner:** A. Mai

**Group Art Unit:** 2814

**Attorney Docket No.:** 3027.1US  
(96-684.1)



CERTIFICATE OF MAILING

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Samuel E. Webb  
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AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed August 28, 2000, the three-month shortened statutory period for response to which expires on November 28, 2000.

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TECHNOLOGY CENTER 2800